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Attorney Docket No. KLAC00012

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I CERTIFY THAT ON JUNE 28, 2002, WHICH IS THE DATE I AM SIGNING THIS CERTIFICATE, THIS CORRESPONDENCE AND IDENTIFIED ENCLOSURES ARE BEING DEPOSITED IN THE UNITED STATES POSTAL SERVICE, POSTAGE PAID FIRST CLASS, IN AN ENVELOPE ADDRESSED TO: COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON, D.C. 20231.

STEVEN W. SMYRSKI

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

CHRISTOPHER FAIRLEY, ET AL.

Title: CONFOCAL WAFER INSPECTION
METHOD AND APPARATUS

Serial No.: 09/533,203

Filed: MARCH 23, 2000

Group Art Unit: 2878

Examiner: Eric J. Spears

PETITION FOR EXTENSION OF TIME

Asst. Commissioner for Patents
Washington, DC 20231

Sir:

In accordance with Rule 136, Applicant respectfully petitions the Commissioner for a one month extension of time extending to June 28, 2002, the period for response to the

07/11/2002 AMAB11 00000077 09533203

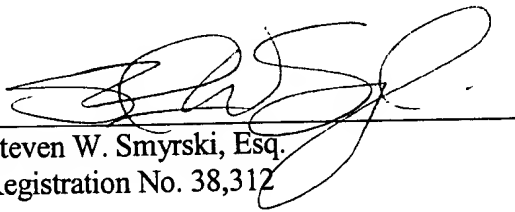
03 FC:115

110.00 OP

Office Action dated February 28, 2002. A check for \$110.00 and the responsive papers are attached.

Respectfully submitted,

Date: June 28, 2002



Steven W. Smyrski, Esq.
Registration No. 38,312

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